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## BIB DATA SHEET

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**APPLICANTS**

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**\*\* CONTINUING DATA \*\*\*\*\***

This application is a 371 of PCT/JP04/04078 03/24/2004

**\*\* FOREIGN APPLICATIONS \*\*\*\*\***

JAPAN 2003-126381 05/01/2003

**\*\* IF REQUIRED, FOREIGN FILING LICENSE GRANTED \*\***

02/12/2007

Foreign Priority claimed	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	Met after Allowance	STATE OR COUNTRY	SHEETS DRAWINGS	TOTAL CLAIMS	INDEPENDENT CLAIMS
Verified and Acknowledged		/WAYNE K LEUNG/ Examiner's Signature		Initials	JAPAN	0	12	1

**ADDRESS**

AZ ELECTRONIC MATERIALS USA CORP.  
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**TITLE**

Coating composition, porous silica-based film, method for producing porous silica-based film and semiconductor device

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